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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re United States Patent Application of:	)	Docket No.: 2771-605 (7486)
Applicants: ROEDER, Jeffrey F. et al.	)	Conf. No.: 3324
Application No.: 10/643,110	)	Art Unit: 2829
Date Filed: August 18, 2003	)	Examiner: Caridad Everhart
Title: PRECURSOR COMPOSITIONS AND PROCESSES FOR MOCVD OF BARRIER MATERIALS IN SEMICONDUCTOR MANUFACTURING	)	Customer No.: 25559

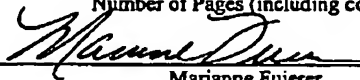
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Marianne Fuierer

April 8, 2005

Date

**RESPONSE TO MARCH 9, 2005 OFFICE ACTION IN U.S. PATENT APPLICATION NO.  
10/643,110**

Mail Stop AF  
Commissioner for Patents  
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Alexandria, Virginia 22313-1450

Sir:

In response to the March 9, 2005 Office Action in the above-identified application, applicants make the following remarks.